PRESSURE SENSITIVE ELEMENT

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EC Classification:

Equivalents:

JP3143858B2

Abstract

PROBLEM TO BE SOLVED: To provide a pressure sensitive element in which thickness is made to be thin, manufacturing is facilitated, and no occurrence of failure resulting from an assembling error is allowed. SOLUTION: A pressure sensitive element is composed of a pressure sensitive film element 20 formed in the center of the bottom face of the dome-like pushing portion 11 of a film 10. The pressure sensitive film element 20 is composed of an electrode pattern 21 formed on the face of the film 10, a pressure sensitive resistant film 25 formed on the electrode pattern 21, an electrode pattern 27 formed on a location opposite to the electrode pattern 21 on the pressure sensitive resistant film 25.

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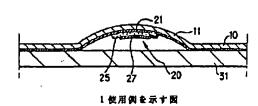
25 感圧抵抗膜

41-4 導電パターン

【図1】 23 (a)

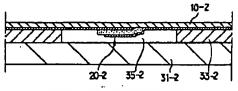
(c) 10 フイルム 20 島圧膜素子 21,27 電極パターン 25 島圧抵抗膜 本発明の惑圧素子を示す図

31-5 基板(基材)



【図2】

【図5】



他の感圧菓子の1使用例を示す図



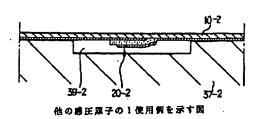
1 使用例を示す図

【図3】

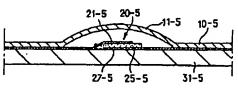
【図4】

1 使用例を示す図





【図9】



他の感圧業子を示す図

